

APPLICATION NUMBER 09/313,659	FILING DATE 05/18/1999	CLASS 438	GROUP ART UNIT 2814	ATTORNEY DOCKET NO SEC. 636
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APPLICANT:
WON-SUK YANG, SEOUL, REPUBLIC OF KOREA; KI-NAM KIM, KYUNGGI-DO,
REPUBLIC OF KOREA; CHANG-HYUN CHO, SEOUL, REPUBLIC OF KOREA.

CONTINUING DOMESTIC DATA***
VERIFIED

371 (NAT'L STAGE) DATA***
VERIFIED

FOREIGN APPLICATIONS***
VERIFIED REPUBLIC OF KOREA 98-18167 05/20/1998

FOREIGN FILING LICENSE GRANTED 06/07/1999

Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY KRX	SHEETS DRAWINGS 16	TOTAL CLAIMS 19	INDEPENDENT CLAIMS 2
Verified and acknowledged _____ Examiner's Name Initials				

ADDRESS
JONES AND VALENTINE LLP
SUITE 150
12200 SUNRISE VALLEY DRIVE
RESTON , VA 20191

TITLE
METHOD OF FABRICATING A MOS TRANSISTOR WITH DOUBLE SIDEWALL SPACERS IN
A PERIPHERAL REGION AND SINGLE SIDEWALL SPACERS IN A CELL REGION

FILING FEE RECEIVED \$**760	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT NO. _____ for the following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of Time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
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